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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kotaro ONO
Serial No. : (U.S. National Stage of PCT/JP2004/011238
filed August 5, 2004)
For : METHOD OF PRODUCING WHEEL AND THE
WHEEL

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is an Information Disclosure Citation (IDC). Copies of
the listed foreign patent documents are provided.

Respectfully submitted,

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		Document Number	Date	Country	Class	Subclass	Translation		
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	F1	JP- 2001-150089	6/5/01	JP			Y* ^F		
	F2	JP- 60-127040	7/6/85	JP			Y* ^{FC}		
	F3	JP- 6-285575	10/11/94	JP			Y* ^{FC}		
	F4	JP- 8-164438	6/25/96	JP			Y* ^F		
	F5	JP- 58-12092	1/24/83	JP				N ^C	
	F6	JP- 6-154932	6/3/94	JP			Y* ^C		
	F7	JP- 61-115641	6/3/86	JP			Y* ^C		
<p>TRANSLATION KEY: * English Abstract. ^F Concise statement of relevance provided in foreign search report. ^C Concise statement of relevance provided in specification. ^S Concise statement of relevance provided in IDS. ^P Relevant portion of reference translated. ^O English abstract only - copy of reference in pct search.</p>									
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